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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

LEWIN et al

Atty. Ref.: SCS-124-1118;
Confirmation No. 4506

Appl. No. 10/534,495

TC/A.U.: 2886

Filed: May 10, 2005

Examiner: R. Punnoose

For: STRUCTURED LIGHT PROJECTOR

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May 27, 2010

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

STATEMENT OF THE SUBSTANCE OF THE INTERVIEW

This Statement is responsive to the Interview Summary mailed by the Patent Office on May 17, 2010. Applicant has reviewed the Interview Summary and it correctly identifies the date of the first interview on April 6, 2010, the fact that it was agreed upon that the Final Rejection of January 8, 2010 was withdrawn and a new office action will be mailed and no further pertinent matters were discussed. However, Supervisory Chowdery was also present. Subsequent telephone conversations with SPE Chowdery and Examiner Punnoose on May 7, May 10 and May 11, 2010 were not indicated, but merely confirms that a PTO Interview Summary would be mailed.

Having responded to all issues, the application is in condition for allowance and notice to that effect is respectfully solicited. In the event the Examiner has any further

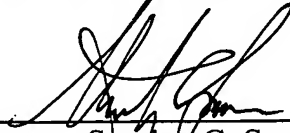
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questions regarding this matter, he is respectfully requested to contact Applicants' undersigned representative.

Respectfully submitted,

NIXON & VANDERHYE P.C.

By: _____



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